



INTERNATIONAL
GEMOLOGICAL
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LABORATORY GROWN DIAMOND REPORT

August 8, 2025

IGI Report Number **LG717581649**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **10.73 - 10.76 X 6.39 MM**

GRADING RESULTS

Carat Weight **4.56 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

Cut Grade **IDEAL**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG717581649**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type Ila

LG717581649
Report verification at igi.org

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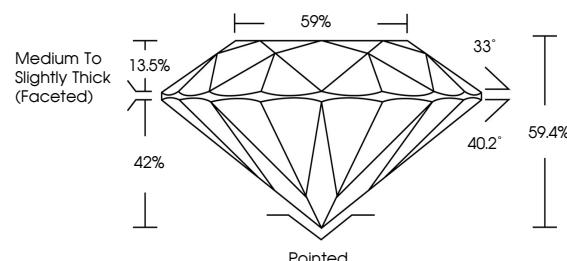
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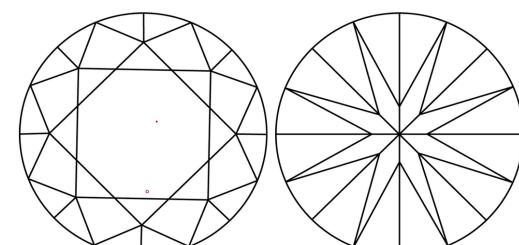


Sample Image Used

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
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Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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